

## INVENTOR INFORMATION

Inventor One Given Name: Shuichi  
Family Name: YABU  
Postal Address Line One:  
City of Residence: Kanagawa  
State or Province of Residence: Kanagawa  
Country of Residence: Japan  
Citizenship Country: Japan

## - CORRESPONDENCE INFORMATION

Correspondence Customer Number: 05514  
\* Fax: (212) 218-2200

## APPLICATION INFORMATION

Title Line One: EXPOSURE APPARATUS, GAS REPLACING METHOD, AND  
Title Line Two: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

Total Drawing Sheets: 20  
Formal Drawings?: Yes  
Application Type: Utility  
Docket Number: 35.G2760  
Secrecy Order in Parent Appl.? : No

## REPRESENTATIVE INFORMATION

Representative Customer Number: 5514

## PRIOR FOREIGN APPLICATION

Foreign Application One: 2000-93687  
Filing Date: 03-30-2001  
Country: JAPAN  
Priority Claimed: Yes